



EFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Eiki Matsuo	)	Group Art No.:	2873
		)		
Application No:	10/826,479	)	Examiner:	Stultz, Jessica
		)		
Filed:	04/16/2004	)	Re:	Response
		)		
For: "Imaging Optical System"		)	Our Ref:	B-4460PCTDIV3 621784-1
		)		
		)	Date:	March 7, 2005

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This paper is filed in response to the official action dated January 10, 2005

Remarks begin on page 2 of this paper.